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TO:	Attn: Examiners Suk San Foong & George R. Fourson III Art Unit: 2823 United States Patent & Trademark Office	
DATE & TIME:	August 23, 2004	
TOTAL PAGES:	Fifteen (15)	
FAX NUMBER:	703-872-9306	
FROM:	Morris, Manning & Martin, LLP	CHARGE TO: 14506-44054
NAME:	Tim Tingkang Xia, Esq.	CLIENT/MATTER:
PHONE:	(404) 233-7000	CONFIRMATION TIME:
		HR MIN SEC

COMMENTS:

Attn: Examiners Suk San Foong & George R. Fourson III

RE: 09/818,193

Please see attached.

Thank you!

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S/N 09/818,193

PATENT
Confirmation No. 3973

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Gilyong Chung, et al Examiner: George R. Fourson III
Serial No.: 09/818,193 Group Art Unit: 2823
Filed: March 26, 2001 Docket No.: 14506-44054
(Formerly 2026.000900/VU0037)
Title: Inclusion Of Nitrogen At The Silicon Dioxide-Silicon Carbide
Interface For Passivation Of Interface Defects

CERTIFICATE UNDER 37 CFR 1.8(a):

I hereby certify that this correspondence is being transmitted by facsimile to number 703-872-9306 addressed to Mail Stop: Non-Fee Amendment, Commissioner for Patents, United States Patent and Trademark Office on August 23, 2004.

By: 
Name: Tim Tingkang Xia

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Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450


CUSTOMER NO. 24728

Sir:

We are transmitting herewith the attached:

- ☒ Transmittal Sheet containing Certificate of Mailing (1 page)
- ☒ Response to June 14, 2004 Office Action (13 pages)

MORRIS, MANNING & MARTIN, LLP
1600 Atlanta Financial Center
3343 Peachtree Road NE
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404-233-700 (Main)
404-495-3678 (Direct)
Customer No. 24728

By: 
Name: Tim Tingkang Xia
Reg. No.: 45,242

S/N 09/818,193

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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By: 
Name: Tim Tingkang Xia

AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 23, 2004

Dear Sir:

In response to the Office Action mailed June 14, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Amendments to the Abstract begin on page 6 of this paper.

Remarks/Arguments begin on page 7 of this paper.